

Supplemental document

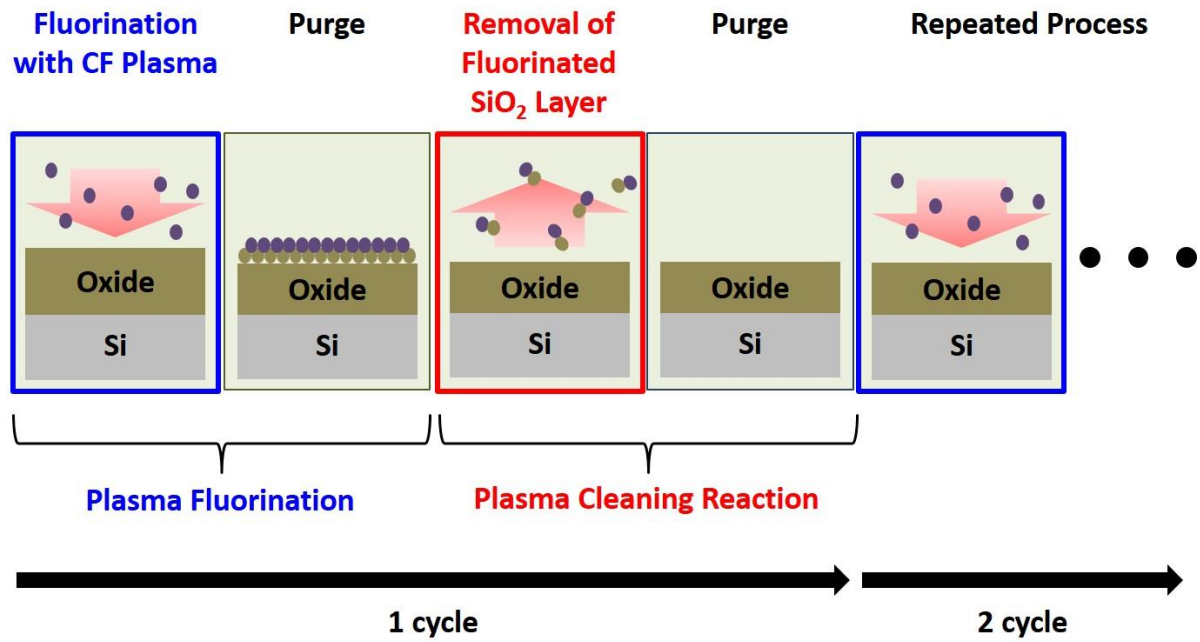


Figure 1. Mechanism of cyclic plasma cleaning process for SiO₂ layers